

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/758,621	WANG ET AL.	
	Examiner Jafar Parsa	Art Unit 1621	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
518	700	7/30/2005	JP
518	715	7/30/2005	JP